



520.37698CX1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: K. TAKAHASHI, et al.

Serial No: 09/414,520

Filed: October 8, 1999

Title: A PLASMA PROCESSING APPARATUS AND A PLASMA  
PROCESSING METHOD

Group: 1763

Examiner: R. ZERVIGON

*Entered 10/18/05*

**AMENDMENT AFTER FINAL REJECTION**

BOX AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

October 3, 2005

Sir:

In response to the Office Action mailed June 2, 2005, please amend  
the above-identified application as listed in the following, and as set forth on  
the following pages:

Amendments to the Claims; and

Remarks are included following the amendments.